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Attorney Docket No. 108298715US
Disclosure No. 03-0117.00/US

PTO/SB/08a/b (08-03)

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/646,673-Conf. #1020
				Filing Date	August 21, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
JS		US-09/651,037	Filed 08-30-2000	Mardian	
		US-10/365,085	Filed 02-11-2003	Carpenter et al.	
		US-10/665,099	Filed 09-17-2003	Basceri et al.	
		US-10/665,908	Filed 09-18-2003	Sarigiannis et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
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		US-10/687,458	Filed 10-15-2003	Kubista et al.	
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JS		US-11/027,825	Filed 12-29-2004	Derderian et al.	

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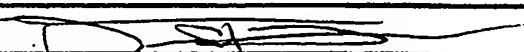
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				Art Unit	1762
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03	US-11/043,629	Filed 01-25-2005	Rueger et al.	
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	US-2001/0011526-A1	08-09-2001	Doering et al.	
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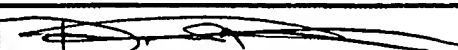
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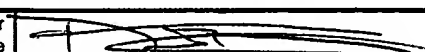
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PTO/SB/08a/b (08-03)

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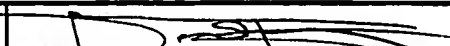
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				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
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

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

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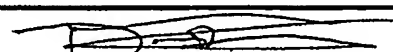
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